CLAIMS

1. A carrier plate that is used in a double-sided machining device which comprises a pair of upper and lower surface plates so as to face each other,

the carrier plate is disposed between the pair of upper and lower surface plates and has a circular shape in plan views,

the carrier plate comprises substrate holding holes, and strip-shaped blades that are formed on at least one surface of the upper and lower surfaces of the carrier plate so as to protrude from the surface,

the strip-shaped blades function as scrapers, which wipe polishing or grinding waste and polishing or grinding liquid toward the outer periphery of the carrier plate,

the strip-shaped blades extend in directions crossing a circumferential direction of the carrier plate in the plan view, and are disposed between the substrate holding holes adjacent to each other.

2. The carrier plate according to claim 1, wherein

the angle θ, which is close to the outer peripheral side of the carrier plate, of angles formed between the extending direction of the strip-shaped portion and the radial direction of the carrier plate is in the range of 0° to 80°.

3. The carrier plate according to claim 2, wherein

the angle is in the range of 1° to 45°.